



Patent Attorney  
Docket No. 032501-006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of )  
NGOI et al. ) Group Art Unit: 2877  
Application No.: 09/407,177 ) Examiner: Hwas Lee  
Filed: September 28, 1999 ) Confirmation No.: 2405  
For: HETERODYNE )  
INTERFEROMETRY FOR SMALL )  
SPACING MEASUREMENT )

AMENDMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the Office Action dated December 3, 2002, please amend the above-identified patent application as follows:

IN THE CLAIMS

Please substitute amended claim 16 as follows:

16. (Twice Amended) A method for high speed and precision measurement of the distance between at least two near contact surfaces, one of which is an optically transparent element and the other is a substantially non-transparent element using heterodyne interferometry, comprising: